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Re:

Applicant(s):

Varun Singh, et al.

Serial No.

09/964,192 9/26/01

Filing Date: For:

AN IMPROVED POLYSILICON RESISTOR HAVING ADJUSTABLE

TEMPERATURE COEFFICIENTS AND THE METHOD OF MAKING

THE SAME

Docket No .:

20661-801D1

Dear Sir:

Transmitted for filing with the Patent and Trademark Office are the following documents for the abovereferenced patent application:

- 1. Information Disclosure Statement
- 2. Form PTO-1449
- 3. References A1 - A4 and C1 - C10
- Postcard acknowledgment

Please address all communications related to this to:

Roger L. Maxwell Jenkens & Gilchrist, P.C. 1445 Ross Avenue, Suite 3200 Dallas, Texas 75202-2799

In the event there is an under or over payment, please debit or credit our Deposit Account #10-0447. This letter is being filed in duplicate to facilitate processing.

Respectfully submitted,

Stylart D. Dwork

Registration No. 31,103

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Docket No. 20661-801D1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	Varun Singh, et al.)	Group Art Unit: 2812	107
Serial No.:	09/964,192)	Examiner: H. Tsai	2800
Filed:	9/26/01)		MAIL

For:

AN IMPROVED POLYSILICON RESISTOR HAVING ADJUSTABLE TEMPERATURE COEFFICIENTS AND THE METHOD OF MAKING THE

SAME

To the Assistant Commissioner for Patents
Washington, D.C. 20231

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Assistant Commissioner for Patents, Washington, D.C. 20231

on 2-1-02

Signature

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

In accordance with Applicant's duty under 37 C.F.R. § 1.56 and 1.97, Applicant hereby submits the attached form PTO-1449 (modified) which lists art cited. The attached art was cited during prosecution of parent application 09/558,905. The art listed therein, while of some relevance, is not necessarily considered to teach or suggest any aspect of the invention described and claimed in the above-identified patent application. This statement is also not to be construed as a representation that a search has, or has not, been conducted or that no better art exists. Rather, this statement discloses only the best art of which the Applicant is aware.

In considering the art set forth below, it may be noted by the Examiner that certain of the references may contain markings, underlinings or other notations. These markings or notations are not to be construed as drawing the Examiner's attention either to selected parts or away from other

parts of the references. Any such markings were either present on the copies of the references obtained by Applicant, or were made thereon during the study of the references by the Applicant and/or his attorneys.

The Examiner is respectfully requested to consider each of the cited references, indicate such consideration by initialing each reference on the enclosed Form PTO-1449 (modified) and return a copy of the same with the next communication to the Applicant. For the convenience of the Examiner in considering the references, copies of the cited references are enclosed with this communication.

Respectfully submitted,

Stuart D. Dwork Reg. No. 31,103

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